

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of Applicants:

Date: July 30, 2007

Haight et al.

Group Art Unit: 1725

Serial No.: 09/933,461

Examiner: J. J. Johnson

Filed: August 20, 2001

Docket No.: YOR919980510US2

For: METHOD FOR MINIMIZING SAMPLE DAMAGE DURING THE ABLATION OF
MATERIAL USING A FOCUSED ULTRASHORT PULSED LASER BEAM

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE COMMUNICATION DATED 01/29/2007 AND
STATUS INQUIRY

The referenced Office Communication states:

“Due to a potential interference, ex parte prosecution is SUSPENDED FOR A PERIOD OF 6 MONTHS from the date of this letter. Upon expiration of the period of suspension, applicant should make an inquiry as to the status of the application.

Applicants request the status of this application.

Respectfully submitted,

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